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# Contents

<i>Preface</i>	
<i>Introduction</i>	<i>viii</i>
1. Vacuum Evaporation	
2. Sputtering	41
3. Ion Beam and Ion-Assisted Deposition	101
4. Reactive Deposition Techniques	141
5. Ionized Cluster Beam Methods	207
6. Chemical Methods of Film Deposition	223
7. Epitaxial Film Deposition Techniques	303
8. Other Methods of Film Deposition	335
9. Summary	353
<i>Index</i>	<i>367</i>